



00862.023488

PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Haruhito ONO et al.

Application No.: 10/787,082

Filed: February 27, 2004

For: DEFLECTOR, METHOD OF MANUFACTURING  
DEFLECTOR, AND CHARGED PARTICLE BEAM  
EXPOSURE APPARATUS USING DEFLECTOR)  
: Examiner: N. Wells  
)  
: Group Art Unit: 2881  
)  
: Confirmation No.: 4298  
)  
: Allowed: February 16, 2005  
)  
: April 12, 2005  
)**Mail Stop Issue Fee**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment Under 37 CFR 1.312 in the above-identified application.

☒ No additional fee is required.

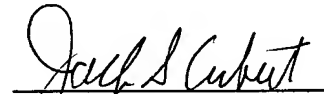
The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	25	MINUS	25	0	x \$25 \$50	\$0.00
INDEP. CLAIMS	13	MINUS	13	0	x \$100 \$200	\$0.00
Fee for Multiple Dependent claims \$180/\$360						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$0.00

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.

- ☐ A check in the amount of \$\_\_\_\_\_ is enclosed to cover the additional claims fee.
- ☐ Charge \$\_\_\_\_\_ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 C.F.R. § 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. §§ 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
- ☐ A check in the amount of \$\_\_\_\_\_ to cover the Extension fee for response within \_\_\_\_\_ additional months is enclosed.
- ☐ A check in the amount of \$\_\_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicants' attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicant  
Jack S. Cubert  
Registration No. 24,245

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AMENDMENT UNDER 37 CFR 1.312

Sir:

In response to the Notice of Allowance dated February 16, 2005, please amend the above-identified application as follows: